## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of :

Miwa WAKE et al. :

Serial No. (not yet assigned) :

Filed: January 28, 2004 :

For: METHOD OF MANUFACTURING :

A SEMICONDUCTOR
INTEGRATED CIRCUIT AND

SEMICONDUCTOR INTEGRATED

CIRCUIT : Docket No. S004-4839(DIV)

MS PATENT APPLICATION COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

## SECOND PRELIMINARY AMENDMENT

S I R:

Applicants preliminarily amend their application as follows:

BY EXPRESS MAIL ON JANUARY 28, 2004 (ER 092 778 261 US)